# Body biasing fault injection: Enhancements, analysis, modeling, and simulation

PhD thesis defense

**Geoffrey Chancel** Jean-Marc Gallière Philippe Maurine

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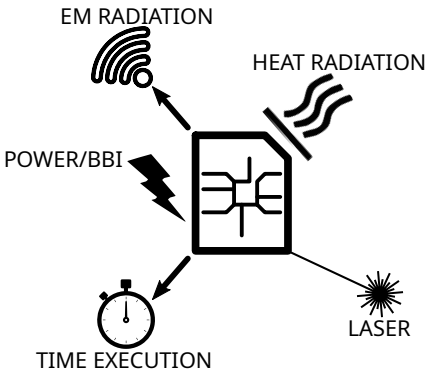
LIRMM

Jean-Luc Danger Giorgio Di Natale Pascal Nouet Jean-Max Dutertre

# INTRODUCTION

# Context: hardware security

- Electronics are found in every economic sector;
- In IoT, CPS, debit cards, phones, bank systems;
- They embed cryptographic algorithms to ensure security;
- These algorithms are fallible, they leak data and can be disturbed.




Side-channel and fault injection.

# Fault injection attacks

Fault injection objectives:

- Denial of service (DoS) $\rightarrow$ Inject faults causing the circuit to stop;
- Verification bypass $\rightarrow$ Inject transient faults modifying data on the fly;
- Confidential data extraction $\rightarrow$ Inject transient faults at specific times.

Thanks to a fault injection platform:

- Power Glitch Fault Injection (PW-GFI);
- Clock Glitch Fault Injection (CK-GFI);
- Laser Fault Injection (LFI);
- Electromagnetic Fault Injection (EMFI);
- Body Biasing Fault Injection (BBI).

# Body biasing injection: state-of-the-art

Limited information in the literature at the beginning of my thesis:

- Philippe Maurine et al. Yet another fault injection technique : by forward body biasing injection;
- K. Tobich et al. Voltage spikes on the substrate to obtain timing faults;
- Noemie Beringuier-Boher et al. Body biasing injection attacks in practice.

A few days after the beginning:

- Colin O'Flynn. Low-cost body biasing injection (BBI) attacks on WLCSP devices.

# Body biasing injection: industrial and academic platforms

Langer EMV-Technik GmbH BBI platform

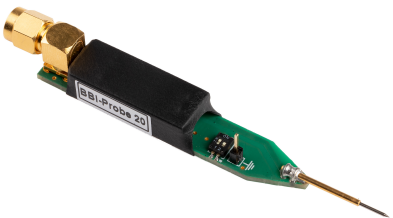
- All-in-one platform;
- A power supply and controller combo called "Burst Power Station";
- An active BBI probe: a current pulse generator, as shown on the right.


Active BBI probe by Langer EMV-Technik GmbH.

# Body biasing injection: industrial and academic platforms

Riscure BV BBI platform:

- All-in-one platform;
- A pulse generator;
- A BBI probe, as shown on the right.

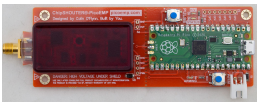



BBI probe proposed by Riscure BV.

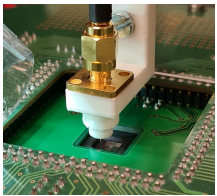
# Body biasing injection: industrial and academic platforms

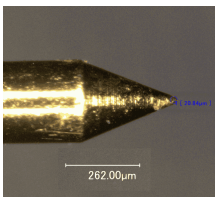
NewAE Technology Inc. BBI platform

- Combined EMFI/BBI pulse generator;



# Body biasing injection: LIRMM BBI platform







- Custom BBI probe;
  - Spring-loaded metal probe;
  - Custom 3D printed housing;
  - SMA connector;
- AVTECH AVRK-4-B high voltage pulse generator.

# Body Biasing Injection: thesis objectives

- What is the spatial resolution of BBI?
- What is the time resolution of BBI?
- Is thinning the substrate useful in any way?
- How faults occur in a BBI context?
- How to model BBI?

# Thesis agenda

- Body Biasing Injection platform enhancements;
- Integrated circuits modeling for BBI;
- Enhanced simulation flow;
- Substrate thinning analysis in a BBI context.
- Conclusion and perspectives

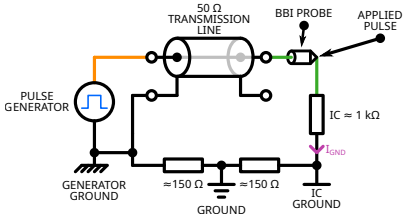
# BODY BIASING INJECTION PLATFORM ENHANCEMENTS

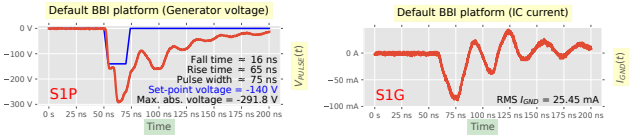
# Typical BBI platform

- BBI introduced to perform Bellcore attack;
- Demanding fault attacks difficult or impossible to perform;
- Low experiment repeatability.

What are the limiting factors?

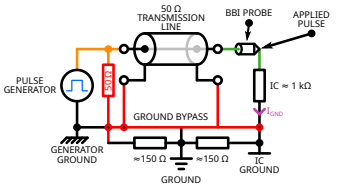
# Typical BBI platform



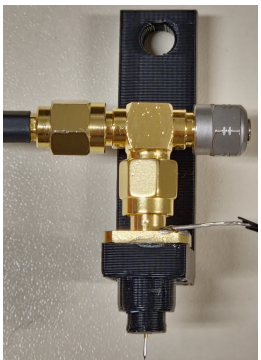




- Impedance mismatch;
- Floating grounds;
- Ringing;
- Set-point error.

# Enhanced BBI platform

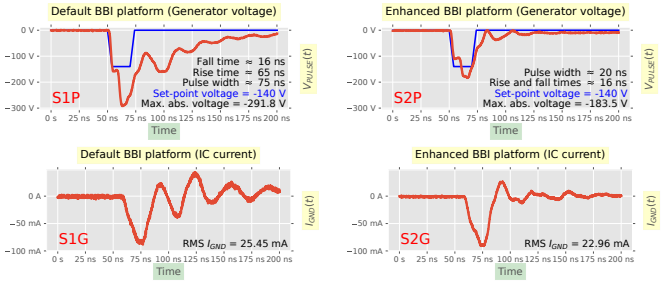






# Enhanced BBI platform

## Summary




Default platform:

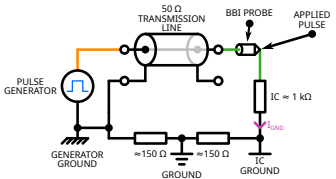
- -108 % pulse undershoot;
- 275 % pulse width overshoot;
- Obvious ringing.

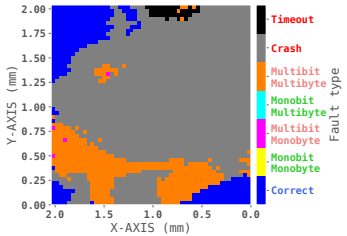
Enhanced platform:

- -31 % undershoot;
- Matched pulse width;
- Less ringing.

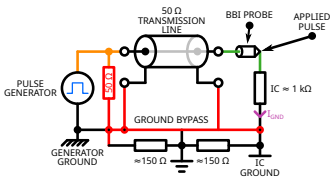
# Enhanced BBI platform benefits

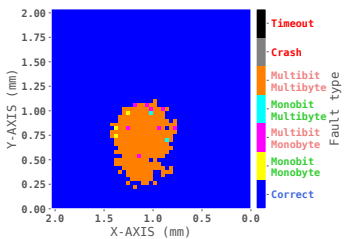
## Giraud's single bit fault attack




Unsuccessful Giraud's DFA




Successful Giraud's DFA

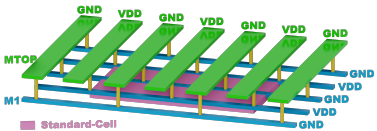
# Giraud's single bit fault attack

## Results

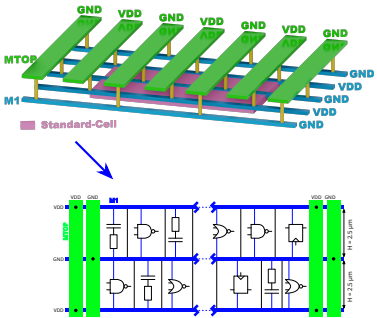
| | 0 | 1 | 2 | 3 | 4 | 5 | 6 | 7 | 8 | 9 | 10 | 11 | 12 | 13 | 14 | 15 |
|---|---|---|---|---|---|---|---|---|---|---|---|---|---|---|---|---|
| K10 | 0xFF | 0x1F | 0x42 | 0xE8 | 0xEF | 0x44 | 0xA5 | 0x6A | 0xCA | 0xE7 | 0x55 | 0x3C | 0xFD | 0x65 | 0x39 | 0x26 |
| KEY | 0x01 | 0x23 | 0x45 | 0x67 | 0x89 | 0xAB | 0xCD | 0xEF | 0xDE | 0xAD | 0xBE | 0xEF | 0x12 | 0x34 | 0x43 | 0x21 |

- 14 bytes out of 16 found thanks to the Giraud's DFA;
- 2 remaining bytes found thanks to brute force.

# Simulation models



# Simulation models



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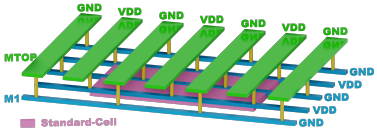


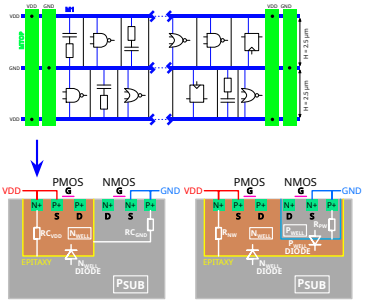

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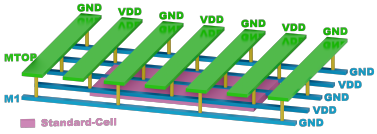


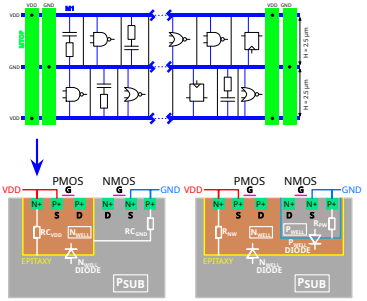


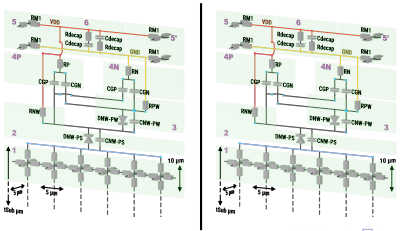

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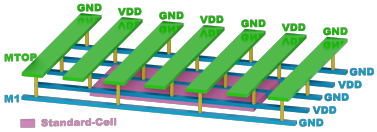


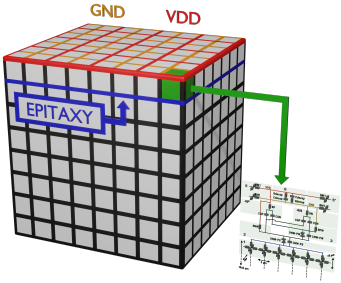


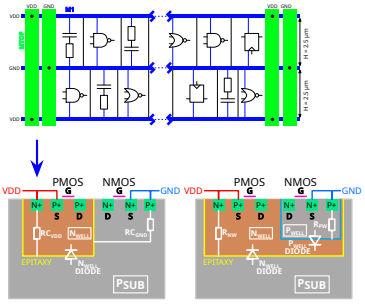


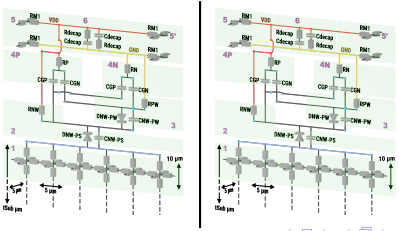

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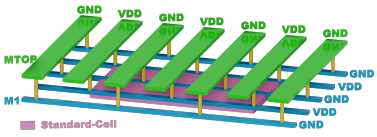


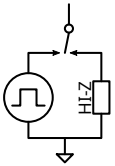


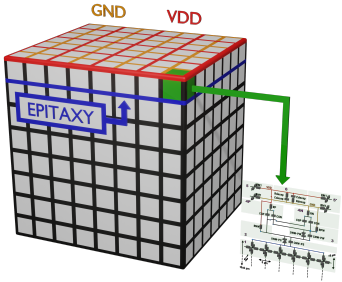


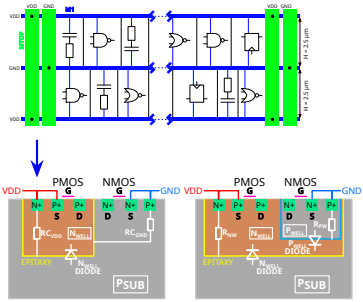


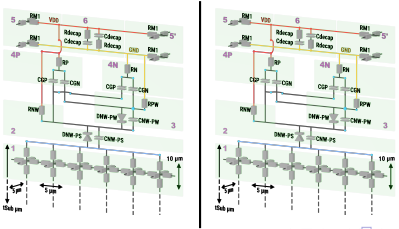

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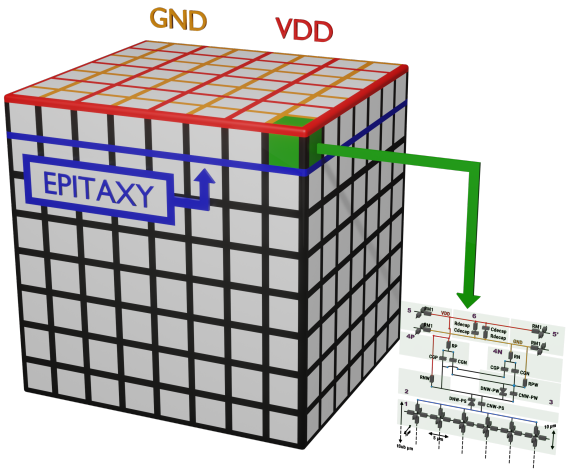


# SIMULATION RESULTS

# Simulation results

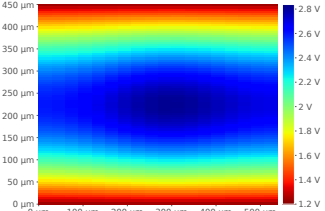
What we observe:

- Dual-well;
- Triple-well;
- Picture at the apex of the pulse;
- 550 $\mu m$ ($W$) $\times$ 450 $\mu m$ ($D$) $\times$ 140 $\mu m$ ($T$): integrated circuit $\rightarrow$ 1620 SCS;

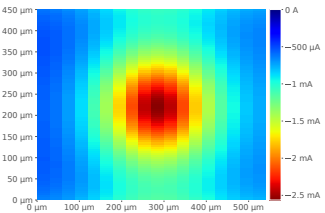
Simulation conditions:

- Voltage pulse amplitude: -300 V;
- Voltage pulse width: 20 ns;
- Rise and fall times: 8 ns;
- Approximate impedance matching.

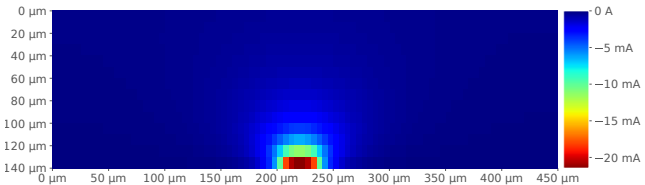
# Simulation results: Dual-Well



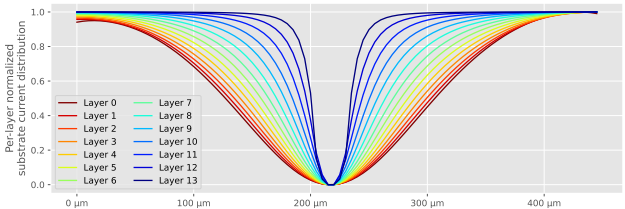

PS voltage distribution




Epitaxy current distribution

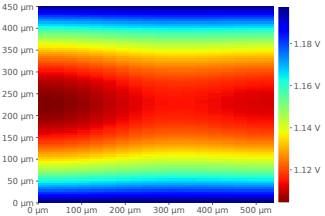



Substrate current distribution

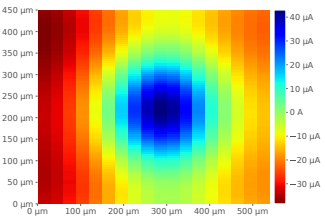



Per-layer normalized substrate current density

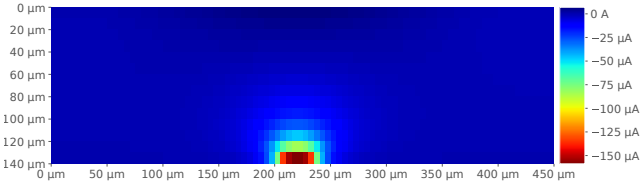
# Simulation results: Triple-Well



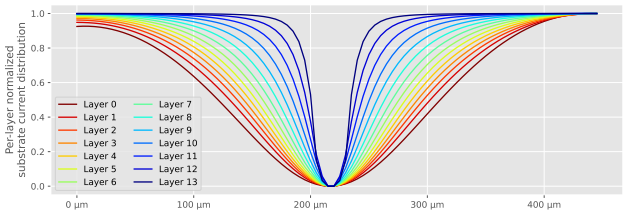

PS voltage distribution




Epitaxy current distribution




Substrate current distribution




Per-layer normalized substrate current density

# Dual-well vs Triple-well

Differences between Dual-well and Triple-well circuits:

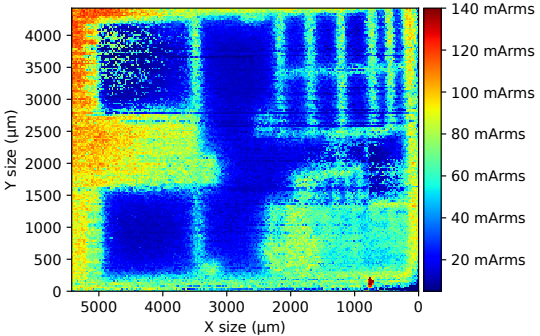
- Dual-well → NMOS are DC-coupled — PMOS are AC-coupled;
- Triple-well → entire IC is AC-coupled.

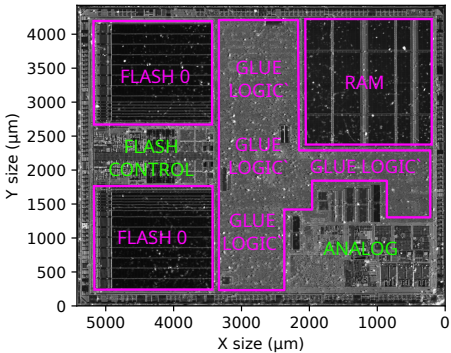
Implications:

- Dual-well → continuous energy flow during the pulse;
- Triple-well → energy flow confined to the pulse edges;

**For a given amount of time → less energy injected into TW compared to DW**
**→ less RMS current into TW compared to DW**

# Dual-Well and Triple-well ICs in practice



# SIMULATION FLOW FOLLOW-UP: HOW FAULTS OCCUR?

## SCS incomplete models: how faults occur?

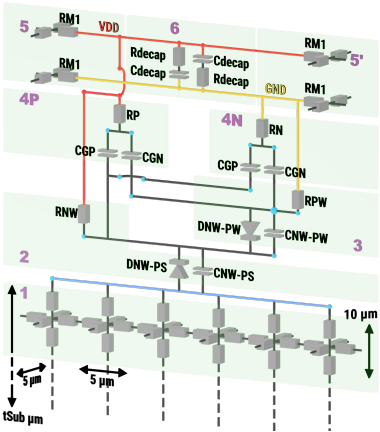
To understand how faults occur

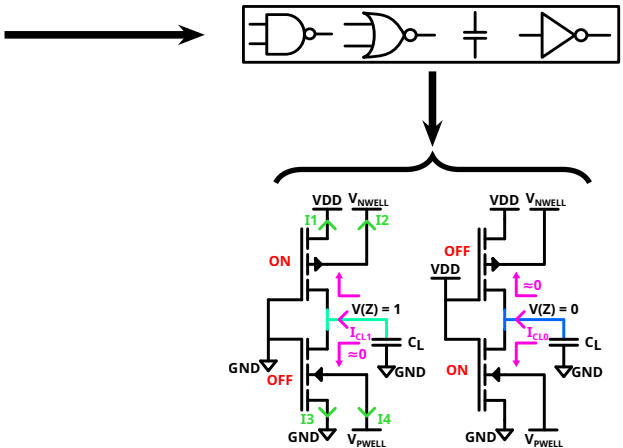
## SCS incomplete models: how faults occur?

To understand how faults occur

We need to consider the logic inside the IC

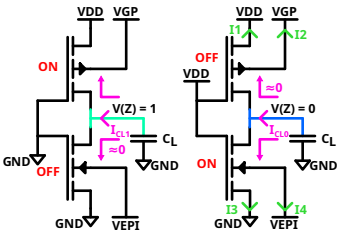
# SCS incomplete models: how to consider logic function?

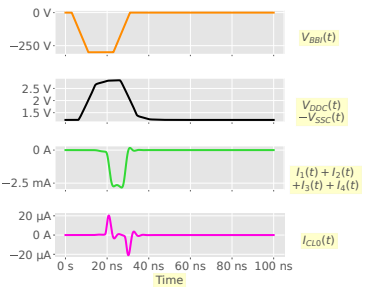


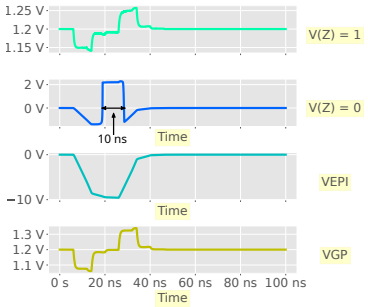



# How faults occur under BBI?

## Dual-well inverters

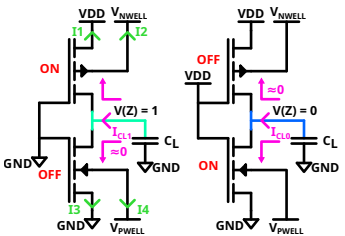


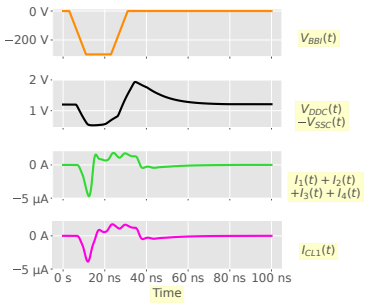



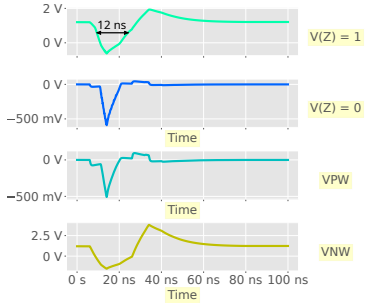



# How faults occur under BBI?

## Triple-well inverters



# How faults occur under BBI?

## Fault model

Data dependent faults:

- Circuits leaks more info;
- Can lead to safe-error attack.

# SUBSTRATE TINNING ANALYSIS

# Substrate thinning in a BBI context

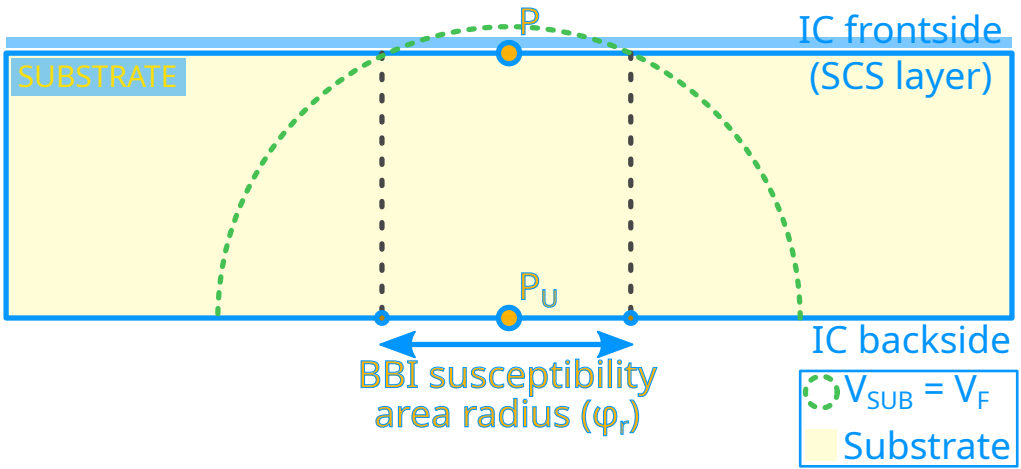
In Laser Fault Injection, substrate thinning has been proven useful
Is it the case concerning BBI?

Section agenda:

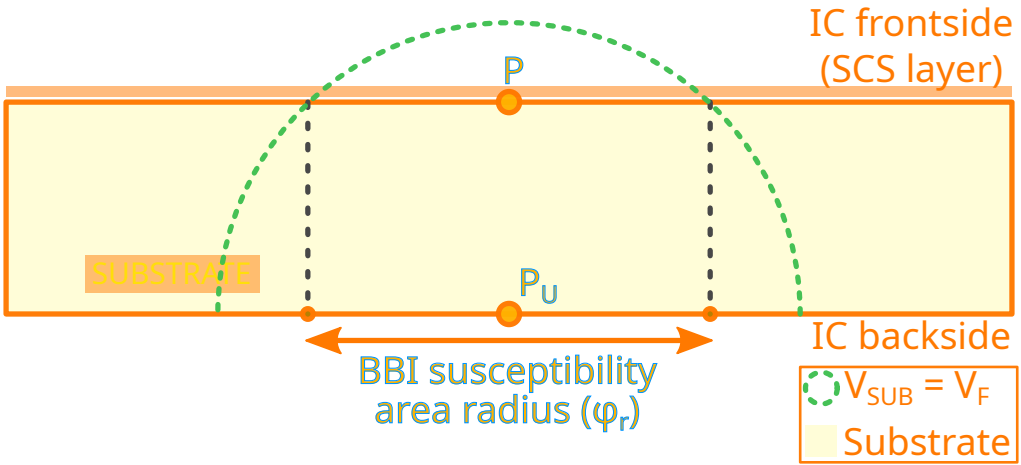
- Geometric approach
- Electrical simulation approach
- Experimental validation

# Geometric approach

# Geometric approach



# Geometric approach



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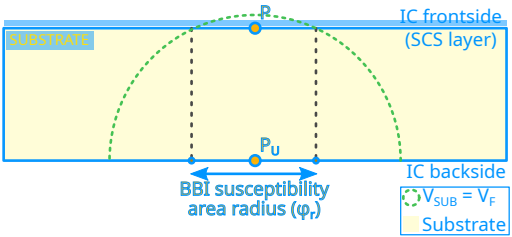


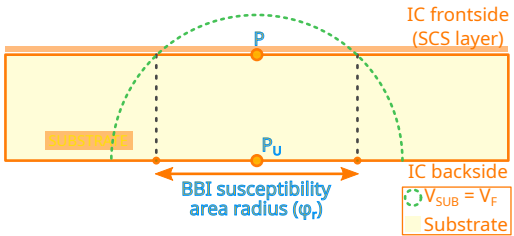

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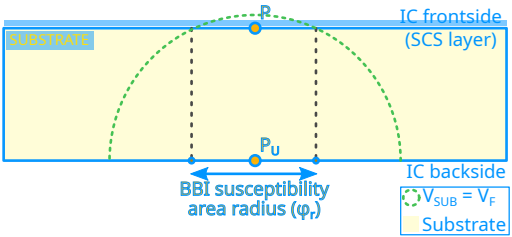
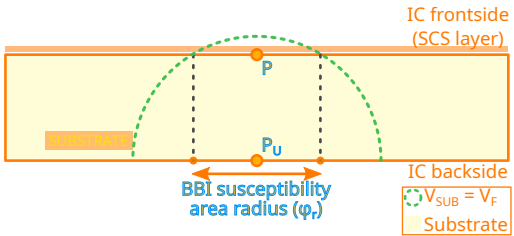


# Geometric approach outcomes

1. Thinning the substrate $\rightarrow$ Reduce the voltage pulse for a given susceptibility area;
2. Thinning the substrate $\rightarrow$ Susceptibility area increases at constant voltage;
3. Thinning the substrate $\rightarrow$ No improvement in resolution.

# Simulation approach

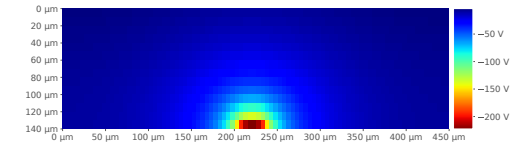
What we observe:

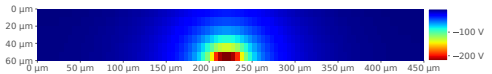
- Dual-well substrate IC;
- Picture at the apex of the pulse;
- 550 $\mu m$ ($W$) $\times$ 450 $\mu m$ ($D$): integrated circuit $\rightarrow$ 1620 SCS;
- 140 $\mu m$ ($T$) IC;
- 60 $\mu m$ ($T$) IC;

Simulation conditions:

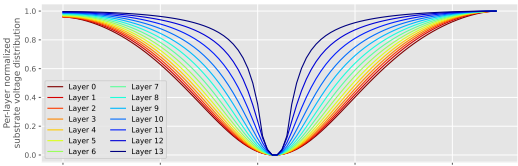
- Voltage pulse amplitude: -300 V;
- Voltage pulse width: 20 ns;
- Rise and fall times: 8 ns.

# Simulation approach




The higher the layer number, the closer to the probe.
The lower the normalized value, the higher the concentration.

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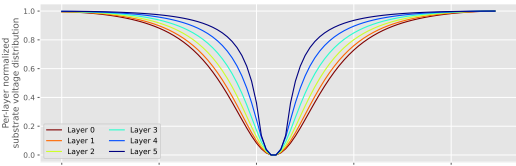


# A few words on substrate thinning techniques

AJOUTER IMAGES APPAREILS AMINCISSEMENT ET EXPLICATIONS

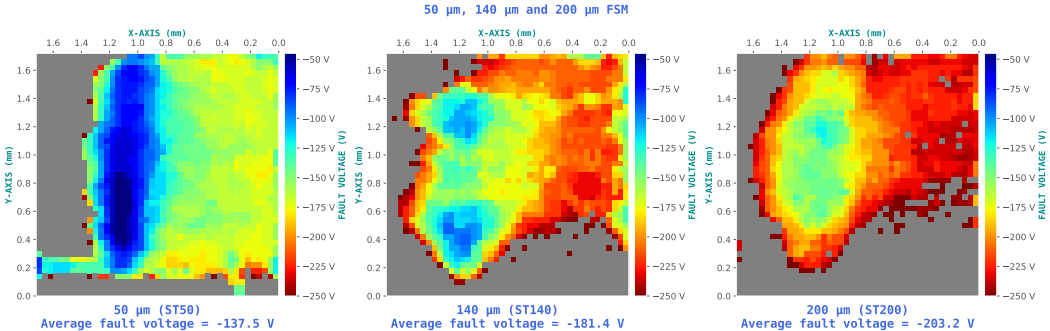
# Substrate thinning in practice

Three experiments to verify the soundness of the outcomes:

- Fault susceptibility maps;
- Susceptibility area spreading maps;
- Susceptibility area comparison.

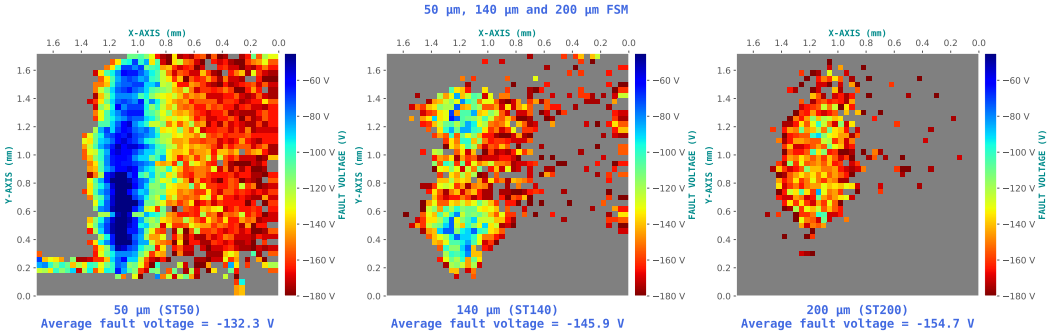
# Substrate thinning in practice

## Fault susceptibility maps



# Substrate thinning in practice

## Susceptibility area spreading



# Substrate thinning in practice

## Fault susceptibility maps couples